

INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO FORM 1449	ATTY. DOCKET NO. 2345/170	SERIAL NO. Not yet assigned
	APPLICANT(s) Hans W. P. KOOPS et al.	
	FILING DATE Herewith	GROUP Not yet assigned

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	PATENT DATE	NAME
AZ	**US 5,263,043	November 16, 1993	John Walsh
AZ	**US 3,586,899	June 22, 1971	Harold Fleisher
AZ	**US 5,268,693	December 7, 1993	John Walsh
AZ	**US 4,727,550	February 23, 1988	Chang et al.

**Cited on German Patent Office Search Report (copy of reference and search report enclosed).

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
				YES	NO
AZ	WO 98/21788	May 22, 1998	PCT	X*	
AZ	WO 87/01873	March 26, 1987	PCT	X*	
AZ	DE 196 09 234	September 11, 1997	Fed. Rep. of Germany	X**	
AZ	WO 98/21788	May 22, 1998	PCT	X**	

*Copy of reference is not enclosed because reference is cited and described in International Search Report (copy of reference provided by International Searching Authority).

**Cited on German Patent Office Search Report (copy of reference and corresponding English abstract and search report enclosed).

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
AZ	*Schoessler C et al., "Nanostructured integrated electron source", Silicon Heterostructures: From Physics to Devices, Barga, Italy, Sept 16-19, 1997, vol. 16, no. 2, pages 862-865, Journal of Vacuum Science & Technology (Microelectronics and Nanometer Structures), March-April 1998, AIP for American Vacuum Soc. USA.
AZ	**JP 0004199885, Abstracts of Japan, Mitsubishi Electric Corp., "Semiconductor Light Emitting Device", July 21, 1992.

*Copy of reference is not enclosed because reference is cited and described in International Search Report (copy of reference provided by International Searching Authority).

**Cited on German Patent Office Search Report (copy of reference and search report enclosed).

EXAMINER AZ	DATE CONSIDERED 9/28/03
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	